### General Atomic Target Fabrication Update

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### General Atomics produces targets and target related equipment

### Targets

- Hohlraums, capsules, flats, foams, high resolution 3D printed, ...
- Diagnostics
  - Fast x-ray diagnostics
- Target fielding equipment



### GA's Target Fabrication and Characterization Advance Laboratory HED Science

• Many capabilities are needed to fabricate various classes of targets



Multiple capabilities are used to make a single target





### Diverse Capabilities, Equipment, and Expertise at One Facility Improves Efficiency





### IFT fabricates high precision capsules in plastic, diamond, and beryllium





### IFT uses a wide variety of coating techniques

- Sputtering
  - Multi-gun
  - Ag, Al, Al<sub>2</sub>O<sub>3</sub>, Au, AuB, Ge, B, Be, B4C, BN, C, Cr, Co, Cu, Dy, Fe, Gd, Ir, Mg, Mn, Mo, Nb, Nd, Ni, Pd, Sc, Si, SiC, SiO<sub>2</sub>, Sn, Ta, Te, Ti, TiO<sub>2</sub>, U, V, W, Zn, Zr
- Electroplating: Au, Ag, Cu, ...
- Spin coating
- Physical Vapor Depositon
  - E-beam evaporator
  - Al, B, Cu, Fe, Ge, Si, Sn, Ta, V, Zr, ...
  - In development Lithium
- Atomic Layer Deposition (ALD)
  - 0.1 layer control, layer/15 sec, conformal
  - Pt, Al<sub>2</sub>O<sub>3</sub>, ZnO, TiN, TiO2 ...
- Diamond (HDC)
- Parylene-N
  - Polymer
- PE-CVD
  - CH and CD polymer doped as requested with Ge, Si, ...





Sputter coating line

ENERAL ATOMICS



## Ultra thin coatings on multiple pane silicon window frames is parallel production method

### **Isochoric Heating Targets**

• Micro-crystalline SiO<sub>2</sub> on 50 nm silicon nitride with silicon frame





- 96 targets per frame
- Facilitates a variety of <u>thin</u> coatings



### We have a new formulation for low density C, H foam ("GACH")

- Densities as low as a few mg/cm<sup>3</sup>
- Sub-micron pore size
- Has also been deuterated (C, D)
- Can be laser machined
- Can be doped (e.g. chlorine)



GACH cast on sticks, first step to machining spheres



Deuterated



Chlorine doped



Bromine doped

• All metal foams can also be produced: Copper or Nickel



### Robotic automation has been used to glue together flats and to mount targets



- Used Robot Assembly station to handle quantity
- Metal coated fused silica chips supplied by customer (2.5x2.5x0.1mm)
  - Supplied ~3 1/2 weeks prior to shot
  - Supplied with edge delamination of metal layer
- 50 µm thick Kapton ablators laser cut
  - Over or under size to miss delamination burr on chip
- Glued ablators (967) and mounted (1003) targets with
  - Combined UV and heat cure with Dymax 605
  - Opaque target need secondary cure



**Parts Tray** 

Mounting Plate Location



### Planar assembly robot has been upgraded to assemble stalks to pins



Planar assembly area

Planar assembly area

One robot handles both planar and stalk assembly



### Machining learning combined with robotics to cull and classify defects automatically



### Defect recognition reaches >90% accuracy



#### Example results from running the code









### >10,000 encased micro-wire targets produced on cylindrical holders for LCLS experiments this past April



- X-ray beam probes Copper plasma just above target surface
- Target foils mounted on cylinders for diagnostic access
  - 3 Cylinders each with >3400 "collimator" micro-wire targets
    - Lithographic process
  - 9 Cylinders with plain foil Copper
  - 3 Cylinders with plain foil Iron



### Lithography and micro-machining techniques used for production





### Targets for laser generated proton isochoric heating of target foils





## Additive manufacturing system using 2 photo polymerization (2PP) has sub micron resolution



- Pulsed lasers peak powers are intense enough to trigger 2 photon absorption
- Pulsed laser average powers are low enough to not destroy the sample

## 3D printing system being upgraded for taller structures and faster writing

- Top down illumination allows tall structures
- Extreme beam shaping profiles will allow parallel writing of voxels or z slices
- Long travel, fast positioning stage allow parts without stitching defects







Arbitrary laser beam profiles will allow entire Z-slice to be written at once with enough laser pulse energy. Currently can write 5 spots at once. (examples next slides were written with one spot)



### Grazing incidence/plasma focusing/multi-tube array targets have been made by high resolution 3D printing/additive manufacturing





### Gradient density foams have been made of large areas without stitching





#### Milli-meter sized parts have been made





#### No stitching defects

(Nanoscribe galvo limited to 140x140µm; large areas are stitched together)









#### 2x2x0.25 mm gradient density foam block



#### CAD translator for printing more complicated parts





lhl

### Gold and silver can be directly written on thin polymer films and other substrates in 2D





Split Ring Resonators



Gold Grid

Working on 3D



### Pure Carbon Hydrogen polymer (CH) printing in development





# GA on team that developed fastest x-ray imager (10ps gate)



Dilation X-ray Imager (DIXI)



Magnetic coils of drift tube



**Capsules** images



 Electron pulse from photocathode drift in magnetic field to stretch out (dilate) in time for read out by slower MCP



### High capacity, high repetition rate target insertion is needed for radiation sources

- Target insertion at high repetition rate
  - Concept we are developing is based on film projector
  - Targets reeled on "film strips"; suspended on fibers or films





### GA with affiliate Umwelt- und Ingenieurtechnik GmbH Dresden (UIT) are developing a supply system for targets for Europe

- UIT (GA affiliate) and GA are forming a partnership
- The future intended contact for target orders for Europe will be :
  - Dr Jens Schubert of UIT, GmbH
  - www.uit-gmbh.de
- Buy in Euro







### Many types of targets, shields, and fiducials have been built for LCLS; most are 2D or 2 1/2 D in nature

Examples of items supplied for LCLS experiments

coated





Ø3mm, 50 um thick fused silica coated with aluminum

Quartz Taraets pyrolytic) w/100nm Al coating on laser facina thin edge



Glassy, Rigid, spacing Diamond multi-step, alued



Ø25.4mm Cylinders with >10.000

micro-dots (holes in resist on aluminum)



Arrav of polypropylene film windows above Ma (left), and MgO (right) chips

#### 1.5 x 3 mm cross section



15 Al and parylene coated polystyrene pillars have total of 750 shot locations

2.5mm sauare 1.2 mm Ø 1.6 mm 50 mm 104 um 450 um Embedded Al 400 um 10 um 20 µm Iron oxide Ti/Cr allov micro-dot thick thick thick powder target taraets. 5 laver Robot arrays Edge mounted gold handle array Assembled and shield Mg and Aluminum steps mounted targets





• Questions?



### Rep-rated facilities, like LCLS and HiBEF, use many targets in an experiment

- Rep-rated: less than 10 min./shot can use hundreds to thousand targets in experiment
- To keep shot rate up, avoid pumping down chamber for each target
  - Load locks
  - Put in arrays of targets onto target positioner in chamber
- MEC at LCLS typically uses arrays of targets
  - Design consideration: target design to reduce fratricide (one target shot damaging another)



- A "Target" is at least a defined feature
  - 1 plain foil shot 4 places counted

as 1 target



 1 foil with 4 features shot 4 places counted as 4 target





#### TSNA Proton focusing targets made by robotic metal forming of mandrels allows many partial gold hemi-shells to be produced

#### In hemi machining process, one is made at a time



